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PATENT APPLICATION

35.C15264

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Examiner: Unassigned
YOSHITAKA NAGAO ET AL.)	Group Art Unit: 1753
Applica	ation No.: 09/824,092)	Gloup Art Omt. 1733
Filed:	April 3, 2001)	
For:	FACING MATERIAL, FABRICATING METHOD THEREOF, SOLAR CELL MODULE, MANUFACTURING METHOD THEREOF, INSTALLING METHOD THEREOF, AND PHOTOVOLTA POWER GENERATING) ;) ; (MC) ;	
	APPARATUS)	July 5, 2001

CLAIM TO PRIORITY

Sir:

Applicants hereby claim priority under the International Convention and all rights to which they are entitled under 35 U.S.C. § 119 based upon the following Japanese Priority Applications: JP 2000-101916, filed on April 4, 2000; JP 2000-101917, filed on April 4, 2000; JP 2000-101918, filed on April 4, 2000; and JP 2001-100013, filed on March 30, 2001.

Certified copies of the priority documents are enclosed.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3801 Facsimile: (212) 218-2200

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